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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Tadahiro OHMI et al.

Title: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME

Application No.: 10/725,063

Filing Date: 12/02/2003

Examiner: Forde, Remmon R.

Art Unit: 2826

**AMENDMENT AND REPLY UNDER 37 C.F.R. 1.111**

Mail Stop Amendment  
 Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, VA 22313-1450

Sir:

This communication is responsive to the Non-Final Office Action dated May 5, 2005, concerning the above-referenced patent application.

**Amendments to the Specification** begin on page 2 of this document.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 4 of this document.

**Remarks/Arguments** begin on page 13 of this document.

Please amend the application as follows: